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APPLICANTS

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** CONTINUING DATA *****

This application is a CIP of PCT/JP02/00268 01/17/2002

✓ KM 6/11/06

** FOREIGN APPLICATIONS *****

JAPAN JP2001-12384 01/19/2001
 JAPAN JP2001-30940 02/07/2001

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** 10/10/2003

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 17	TOTAL CLAIMS 30	INDEPENDENT CLAIMS 5
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after				
Verified and Acknowledged Examiner's Signature: <i>[Signature]</i> Initials: <i>6/11/06</i>				

ADDRESS

23353

TITLE

Substrate processing method and substrate processing apparatus

FILING FEE RECEIVED 1098	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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